

Notice of References Cited	Application/Control No. 10/563,993		Applicant(s)/Patent Under Reexamination REICHENBACH ET AL.	
	Examiner PUNAM PATEL		Art Unit 2855	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,021,766 A	05-1977	Aine, Harry E.	338/2
*	B	US-5,521,123 A	05-1996	Komatsu et al.	438/64
*	C	US-5,729,019 A	03-1998	Krafthefer et al.	250/353
*	D	US-5,841,137 A	11-1998	Whitney, Julie G.	250/338.5
*	E	US-6,652,452 B1	11-2003	Seifert et al.	600/140
*	F	US-2006/0063292 A1	03-2006	Landsberger, LeslieM	438/051
*	G	US-7,402,453 B2	07-2008	Derderian et al.	438/64
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 2004114403 A1	12-2004	World Intellect	LUDWIG et al.	H01L 23/31
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	G. R. Lahiji and K. D. Wise, "A batch-fabricated Silicon Thermopile Infrared Detector", IEEE Transactions on Electron Devices, Vol. ED-29, No. 1, 1982
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.